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PATENT & TRADEMARK OFFICE

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Steven W. Smyrski
Name

Signature

05/29/2001
Date

PATENT
1208-246275

15/ Pre-Amdt
G.J Gonfa
6-22-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	Art Unit: 2877
NIELSEN, HENRIK K. ET AL.	Examiner: R. ROSENBERGER
Serial No: 09/195,533	
Filed: November 18, 1998	
For: DETECTION SYSTEM FOR NANOMETER SCALE TOPOGRAPHIC MEASUREMENTS OF REFLECTIVE SURFACES	

AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION (RCE) APPLICATION

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated February 28, 2001 in connection with the above-identified application, please enter and consider the following amendment and remarks.